



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application Number : 10/811,152 Confirmation No. 8475
Applicant : Ga Won LEE
Filed : March 29, 2004
Tech Cntr/AU : 2812
Examiner : Lynne Ann Gurley
Entitled : METHOD OF FORMING INTER-DIELECTRIC LAYER IN
SEMICONDUCTOR DEVICE
Attorney Reference : 123034-05004767
Customer Number : 43569

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

Responsive to the Office Action mailed July 31, 2006, Applicant herewith submits the following amendments and remarks.

Entered
w/ RCE